



Docket No. 99-113A
PATENT APPLICATION

1732
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17-1782

I certify that on the date specified below this correspondence is being deposited with the United States Postal Service with sufficient postage as first-class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231.

Date June 17, 2002

John C. Hammar
John C. Hammar

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Applicants:	John C. Waldrop III, <i>et al.</i>	Group Art Unit:	1732
Application No.:	09/731,945	Examiner:	
Filing Date:	December 7, 2000	Docket No.:	99-113A
		Date:	June 17, 2002
For:	<i>Double Bag Vacuum Infusion Process and System for Low Cost, Advanced Composite Fabrication</i>		

Assistant Commissioner for Patents
Washington, D.C. 20231

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INFORMATION APPLICANT CITES THAT MAY BE MATERIAL TO THE PROSECUTION OF THE APPLICATION

Sir:

This Supplemental Information Disclosure Statement supplements the Supplemental Information Disclosure Statement mailed October 2, 2001, which supplements the Information Disclosure Statement mailed February 21, 2001.

This Report is being submitted within three months after first learning of this reference by virtue of it being cited in related application 09/878,825 and prior to the first Examiner's Action.